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Front Matter: Volume 6890

, "Front Matter: Volume 6890," Proc. SPIE 6890, Optical Components and Materials V, 689001 (11 March 2008); doi: 10.1117/12.791597

SPIE.

Event: Integrated Optoelectronic Devices 2008, 2008, San Jose, California, United States

PROCEEDINGS OF SPIE

Optical Components and Materials V

Michel J. F. Digonnet
Shibin Jiang
John W. Glesener
J. Christopher Dries
Editors

21–23 January 2008
San Jose, California, USA

Sponsored and Published by
SPIE

Volume 6890

Proceedings of SPIE, 0277-786X, v. 6890

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Author(s), "Title of Paper," in *Optical Components and Materials V*, edited by Michel J. F. Digonnet, Shibin Jiang, John W. Glesener, J. Christopher Dries, Proceedings of SPIE Vol. 6890 (SPIE, Bellingham, WA, 2008) Article CID Number.

ISSN 0277-786X

ISBN 9780819470652

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

SPIE.org

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Printed in the United States of America.

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